

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Seong Deok Ahn et al.

Application No.: 10/672,013

Filed: September 26, 2003

Examiner: Richard R. Bueker

Art Unit: 1763

Confirmation No.: 7684

For: **Method and Apparatus Using Large-Area
Organic Vapor Deposition for Formation of
Organic Thin Films or Organic Devices**

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Commissioner for Patents
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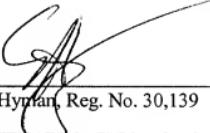
of this Information Disclosure Statement, please charge those fees to our Deposit Account No. 02-2666.

Respectfully submitted,

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Dated: August 8, 2007

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I hereby certify that this correspondence is being submitted electronically via EFS Web on the date shown below


Marilyn Bass August 9, 2007

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/672,013
				Filing Date	September 26, 2003
				First Named Inventor	Seong Deok AHN
				Art Unit	1763
				Examiner Name	Richard R. Bueker
Sheet	1	of	1	Attorney Docket Number	2013P107

Examiner Signature	Date Considered
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

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Based on PTO/SB/08A (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wtr) 08/11/2003.

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